Application/Control No.	Applicant(s)/Patent under Reexamination	
10/517,034	ZEMLOK ET AL.	
Examiner	Art Unit	
Stephen Choi	3724	

SEARCHED					
Class	Subclass	Date	Examiner		
30	122 388 389 390 391 517-524	6/9/2007	sc		
173	216 217	6/9/2007	sc		
173	93.5	6/9/2007	sc		
updated	search	12/7/2007	sc		
83	13	12/7/2007	sc		
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INTERFERENCE SEARCHED					
Class	Subclass	Date	Examiner		
see	above	12/7/2007	sc		

SEARCH NOTES (INCLUDING SEARCH STRATEGY)				
	DATE	EXMR		
consulted 10/165,167 & 11/122,311	6/9/2007	sc		